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To: Examiner Kevin V. Quinto Technology Center 2800	Total Pages Sent: 13 (including cover sheet)
Facsimile Number: 571-273-8300	Transmission Date: September 21, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

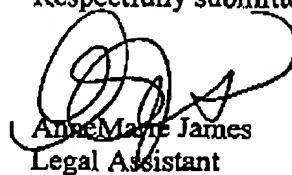
Applicant: Cheng, et al. Docket No.: TSM03-0698
 Serial No: 10/786,643 Art Unit: 2826
 Date Filed: February 25, 2004
 Title: Method and Structure for CMOS Devices with Stress Relaxed by Ion Implantation of Carbon or Oxygen Containing Ions

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- Certification of Facsimile Transmission (1 page)
- Amendment (12 pages)

Respectfully submitted,



Anne Marie James
Legal Assistant

Confirmation Respectfully Requested

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Mail Stop: Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed June 21, 2005. Please amend the above-referenced application as follows.